

filed 5/13/04

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

<b>Title of Invention</b>	<b>ETCHING OPENINGS OF DIFFERENT DEPTHS USING A SINGLE MASK LAYER METHOD AND STRUCTURE</b>						
<p>Application Number : 101209564</p> <p>Confirmation Number:</p> <p>First Named Applicant: David Dobuzinsky</p> <p>Attorney Docket Number: FIS920040046us1</p> <p>Art Unit: 2823</p> <p>Examiner: Pham</p> <p>Search string: ( 6709978 or 6710447 or 6667223 or 6617224 or 6541349 or 6180489 or 6303733 or 6426558 or 6303447 or 6430028 or 6387765 or 6444542 or 6124421 or 6214423 or 6348374 or 6124216 or 6008540 or 6339002 or 5422309 or 6110648 or 6265303 or 6221780 or 6255211 or 6566276 or 6406963 or 6361837 or 6211035 or 6351039 or 6472312 or 6025276 ),pn</p>							
<b>US Patent Documents</b>							
<b>Note: Applicant is not required to submit a paper copy of cited US Patent Documents</b>							
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
Top	1	6709978	2004-03-23	Geusic et al			
	2	6710447	2004-03-23	Nogami			
	3	6667223	2003-12-23	Seitz			
	4	6617224	2003-09-09	Yu et al			
	5	6541349	2003-04-01	Arthanari et al			
	6	6180489	2001-01-30	Yang et al			
	7	6303733	2001-10-16	Lau et al.			
	8	6426558	2002-07-30	Chapple-Sokol et al			
	9	6303447	2001-10-16	Chhagan et al			
	10	6430028	2002-08-06	Kar-Roy et al			
	11	6387765	2002-05-14	Chhagan et al			
	12	6444542	2002-09-03	Moise et al			
	13	6124421	2000-09-26	Lau et al			
	14	6214423	2001-04-10	Lee et al			
	15	6348374	2002-02-19	Athavale et al			
	16	6124216	2000-09-26	Ko et al			
	17	6008540	1999-12-28	Lu et al			
V	18	6339002	2002-01-15	Chan et al			
Top	19	5422309	1995-06-06	Zettler et al			

WP	20	6110648	2000-08-29	Jang			
	21	6265303	2001-07-24	Lu et al			
	22	6221780	2001-04-24	Greco et al			
	23	6255211	2001-07-03	Olsen et al			
	24	6566276	2003-05-20	Maloney et al			
	25	6406963	2002-06-18	Woerlee et al			
	26	6361837	2002-03-26	Pangrie et al			
	27	6211035	2001-04-03	Moise et al			
	28	6351039	2002-02-26	Jin et al			
	29	6472312	2002-10-29	Bao et al			
WP	30	6025276	2000-02-15	Donohoe et al			

## Signature

Examiner Name	Date
<i>Michael Han</i>	12/16/04